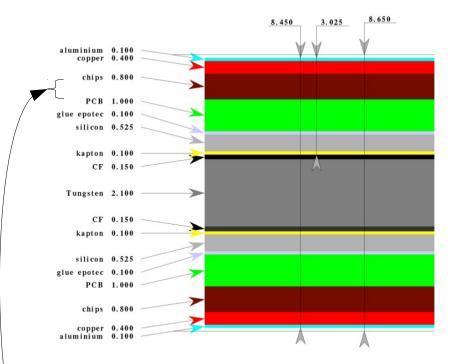
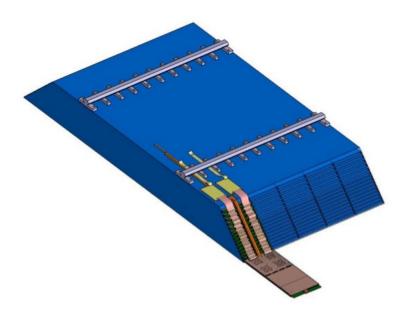


# **News on the Chip-On-Board PCB**

Adrián Irles, DE L'ACCÉLÉRATEUR IINÉAIRE JNG KYUN KWAN ... on behalf of MEGA DE L'ACCÉLÉRATEUR Microelectronics Support by is acknowledged LPN KYUSHII UNIVERSITY CALICE Meeting, Utrech 11/04/2019

#### **Motivation**





Drawings by Henri Videau for SiW Ecal Technical Design Document

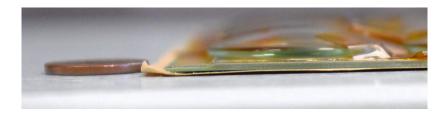
Design: Total space for ASICs and PCB 1.8mm (was 1.2mm since ~2007)

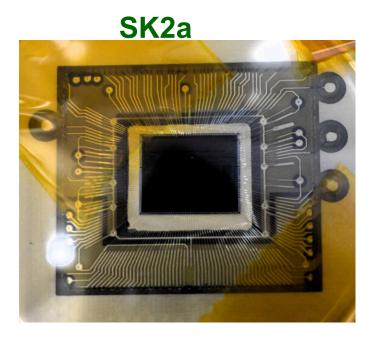


#### **Ultra thin PCB: Chip On Board**



- LAL & OMEGA collaboration with ITAEC/SKKU (Sungkyunkwan University, Suwon – Corea) and EOS company for the PCB production.
- > 10 FEV11\_COB produced.
  - 1.2mm thickness  $\rightarrow$  9 layers PCB !
  - Good Planarity (metrology made in LAL) and electrical response.
- 4 boards wirebonded at CERN bonding lab. Also In contact with CAPTINNOV Platform.







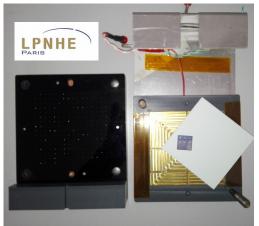
# **Ultra thin PCB: Chip On Board**

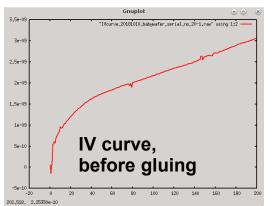
- > Tests ongoing since April 2018:
  - FEV11\_COB\_a: all chips respond and are configured (with SMBV4+DIF system and also SL-Board).
  - FEV11\_COB\_b: equipped with 3 baby wafers. Most of the following results are obtained with this board.
  - FEV11\_COB\_c and d. Just been wirebonded this week.



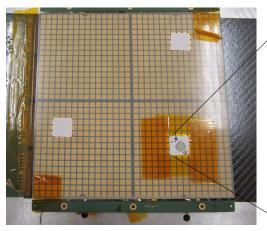


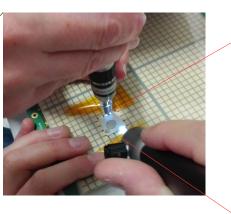
# **Baby wafer gluing**



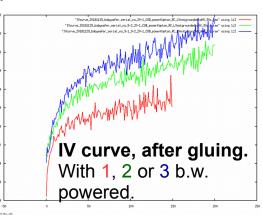


- We got a bunch of S10938-1364(X) "old" baby wafers (split guard rings, 4 rings, cut size B) of 3x3 pixels from T. Suehara.
- IV test bench borrowed from LPNHE. New expertises acquired at LAL (exported to Captinnov). Full wafer characterization will be done at LPNHE.
- > 3 baby wafers manually glued.
  - Visual inspection of the glue dots (light fiber system).
  - IV curves after gluing.





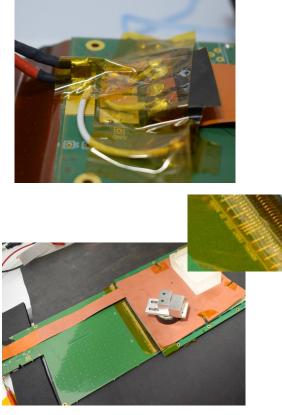






#### **Test bench**

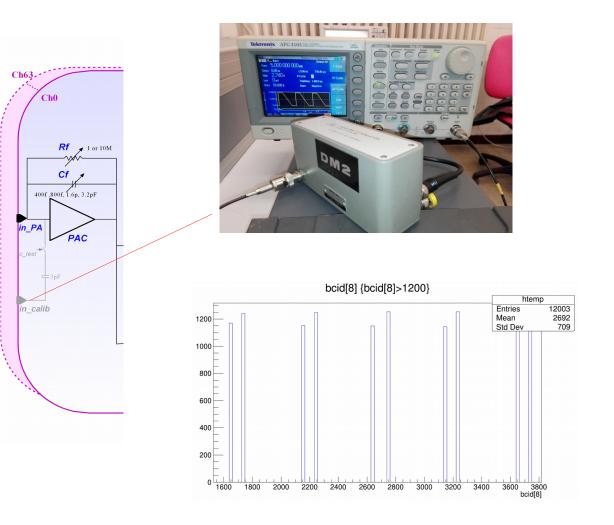




- FEV11\_COB wire bonded to SMBv4 (+ DIF)
  - Modification of an SMBv4 prepared for the tests of individual ASU BGA based using temporary connexions by pressure.
  - These connectors were optimized for thicker ASUs... Solution: wire bond the ASU and SMBV4.
- HV directly connected to the kapton sheet connectors (small RC fitler added).
- The baby wafers are polarized by direct contact with the kapton sheet.

# **Injection tests**

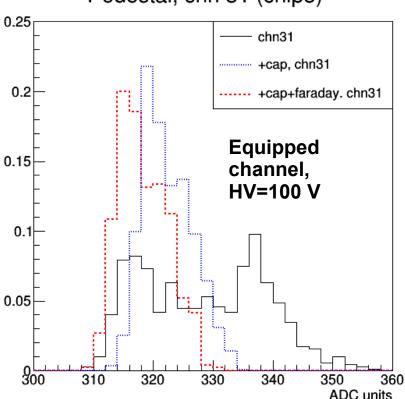
- Tests injection signals equivalent to 1-O(100) MIPs
  - Assuming Si sensors of 320 ± 15µm.
  - And that a MIP traversing the PIN parallel to its normal will create ~ 80 h + e −pairs per µm → ~4.1fC in total.
- > Pedestal measurement:
  - We inject in one single channel per ASIC and we disable the triggers of all the others.





# Injection tests (pedestal study)

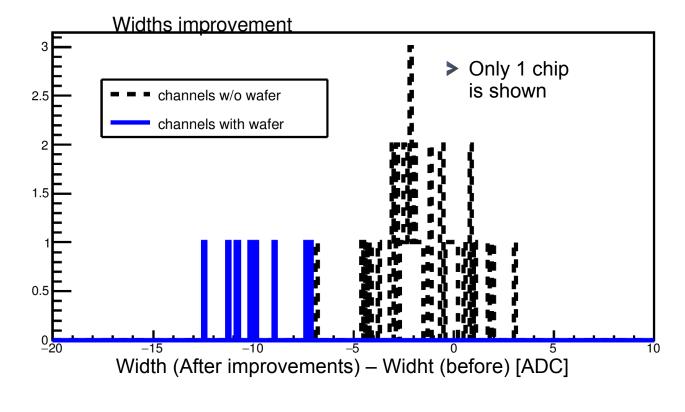
- First pedestal studies showed wider pedestal distributions compared with the expectations.
- This effect is much larger for channels connected to sensors.
- To minimize this effect, we improved the HV delivery and light isolation +:
  - Add AVDD and DVDD decoupling capacitances at the end of the SLAB (blue curve)
  - Further improvement on the HV delivery, Ight and electrical isolation (red curve)



Pedestal, chn 31 (chip8)

### **Injection tests (pedestal study)**

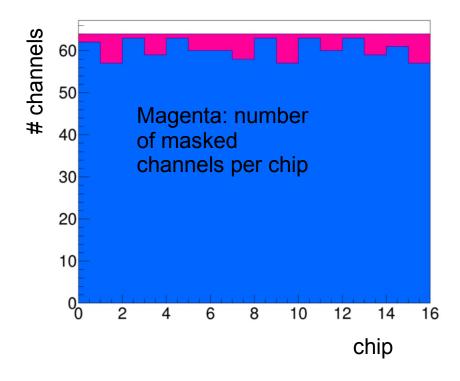
- > What is the improvement in the width of the pedestal for each channel?
  - Width defined as the RMS.

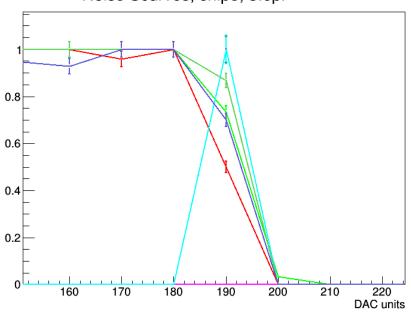




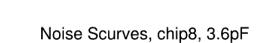
### **Threshold optimization + noisy channels masking**

- > ~4% of noisy channels masked
- > Threshold scans made with all other channels enabled.





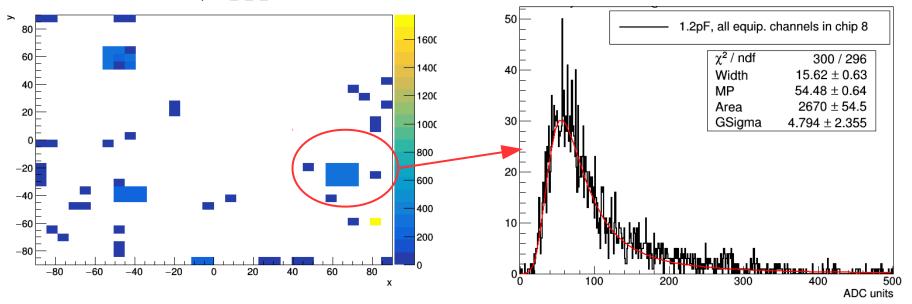
Only equipped channels are shown



#### LA BORATOIRE DE L'ACCÉLERATEUR LINGALERE

#### **Cosmic data**

 Using settings from the commissioning described before



Hits map, dif\_1\_1\_1



#### **Conclusion + outlook**

- > The COBs are fully functional and nicely recording cosmic ray data.
- Ready for wafer gluing
  - LPNHE got a naked COB to test the feasibility of the gluing using the robot. Positive results of the test. See Roman's talk.
- > COBs are been tested with SMBV4+DIF and also with the new SL-board DAQ system.
- Next beam test plans: produce and commission two COBs with glued wafers and connected to SLboards. See Roman's talk.

